

### 3D Optical Profiler

Spectroscopic reflectometer





## Basic features of your S neox with spectroscopic reflectometer

Spectroscopic reflectometer can be integrated for thin films measurement. Transparent films from 50 nm to  $20 \mu m$  can be measured in less than one second with a thickness resolution of 0.1 nm and a lateral resolution up to  $8 \mu m$ . S neox can measure a stack of up to  $10 \mu m$  layers.

Spectrometer reflectometer thickness measurement is only available when the system includes the spectroscopic reflectometer USB2000+ or NANOCALCXR hardware option. The spectroscopic reflectometer controller is connected to the S neox system and can be independently operated using the NanoCalc software.

SensoSCAN integrates the spectroscopic reflectometer thickness measurement by starting NanoCalc software at start up, and commanding it to measure and analyze the thin film layer structure. SensoSCAN retrieves the measured thicknesses of the layers (up to 3).

#### **Specifications**

CONTROLLER		USB2000+			NANOCALCXR	
Wavelendth	400-850 pm			250-1050 nm		
Thickness range <sup>1</sup>	50 nm – 20 μm			10 nm – 100 μm		
Resolution	0.1 nm					
Repeatability	0.3 nm (50nm – 1μm) 1 nm (> 1 μm)			0.3 nm (10nm – 1μm) 1 nm (> 1 μm)		
Absolute Accuracy	< 1% (100 nm – 100 μm)					
Dimensions	89.1 x 63.3 x 34.4 mm			180x152x263 mm		
Weight	~ 190 g			~ 3.5 kg		
OPTIC FIBER		- 170 g			5.5 kg	
Diameter (µm)	200			100		
OBJECTIVES	5X	10X	20X	20X	20X	50X
Туре				SLWD	ELWD	SLWD
NA <sup>2</sup>	0.15	0.30	0.45	0.30	0.40	0.40
WD (mm)	23.5	17.5	4.5	30.0	19.0	22.0
Spot size <sup>3</sup>	80	40	20	20	20	8
COMPLEMENTS						
Step wafer	No			Yes		
Support stage		No			Yes	

#### NOTES

<sup>&</sup>lt;sup>1</sup> Depending on the materials structure, it can measure layers up to 10 nm. For example, SiO2 on Si.

<sup>&</sup>lt;sup>2</sup> The objective numerical aperture has to be lower than 0.45.

<sup>&</sup>lt;sup>3</sup> The lateral size of the measured spot depends on the optical fiber (FO) and the magnification of the brightfield microscope objective. Spot Size= (2\*Diameter FO)/(Objective Magnification).







REXR10L100SNEOX00 | REFLE ESPE XR 10 L 100um SNEOX

#### Software features

NANOCALC SOFTWARE FEATURES		
Fast Fourier Transform algorithms		
Quick Click Controls including sliders for thickness and N&K parameters		
Easy interface customization		
Easy data export		
Local language software versions		
Windows 7		
Thickness measurements from 10 n m to 250 μm for up to 10 layers		
Fast curve fit algorithms in <1 s per measurement		
Customized methods with password protection		
Green-Yellow-Red light answers for online applications		
Large materials database		

To carry out a thin film thickness measurement, the NanoCalc software uses a reference and a layer structure. In order to check or modify references and layer structures, the NanoCalc software interface must be used.

#### Complements

REFERENCE STEP WAFER

RE05 Reference 5 steps (100mm)

It consists of a 4inch Si-wafer with 6 silicon dioxide (SiO2) steps between 0nm (native Oxide) and 500nm. Each thickness step has a laser marked area for which accurate ellipsometric thickness data are supplied on the corresponding calibration sheet.





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